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	Application No.	Applicant(s)	
Notice of Allowability			
	10/713,214 Examiner	CHOI ET AL.  Art Unit	
	Mai-Huong Tran	2818	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to 11/17/03.			
2. ☑ The allowed claim(s) is/are <u>1-14</u> .			
3. The drawings filed on 17 November 2003 are accepted by the Examiner.			
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority u <ul> <li>a)  All</li> <li>b)  Some*</li> <li>c)  None</li> <li>of the:</li> </ul> </li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority do</li> <li>International Bureau (PCT Rule 17.2(a)).</li> </ul> <li>* Certified copies not received:</li>	e been received. e been received in Applicatio	n No	n from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requi	rements
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") mu  (a) ☐ including changes required by the Notice of Draftsper  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner	son's Patent Drawing Review -		
Paper No./Mail Date  Identifying Indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on th the header according to 37 CF	ne drawings in the front (not the ba R 1.121(d).	ack) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT</li> </ol>	osit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIO	ERIAL must be submitted. Not DLOGICAL MATERIAL.	e the
Supervi	6. Interview St Paper No./ 08), 7. Examiner's	formal Patent Application (PTO-1 ummary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allowa	

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## DETAILED ACTION

## Reason for allowance

The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed Nonvolatile Memory Device Utilizing a Vertical Nanotube having a first end of the nanotube array in contact with the source region; a memory cell formed around an outer side surface of the nanotube array; a control gate formed around an outer side surface of the memory cell; and a drain region in contact with a second end of the nanotube array.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

## Conclusion

Any inquiry concerning this communication on earlier communications from the examiner should be directed to Mai-Huong Tran, (571) 272-1796. The examiner can normally be reached on Monday-Thursday from 8:00 AM to 6:30 PM. The examiner's supervisor, David Nelms can be reached on (571) 272-1787.

The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR, Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mai-Huong Tran

Dávid Nelms
Supervisory Patent Examiner
Technology Center 2800